

Search Notes

Application/Control No.

10/765,392

Examiner

John Rivell

Applicant(s)/Patent under
Reexamination

KURITA ET AL.

Art Unit

3753

SEARCHED

Class	Subclass	Date	Examiner
137	554	1/12/2006	
324	207.12	1/12/2006	
324	207.21	1/12/2006	
324	207.25	1/12/2006	
336	84M	1/12/2006	

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
Interference Search History Printout		1/12/2006	

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST (US, USPGPub, USOCR, JPO, EPO, DERWENT< IBM Tech)	1/12/2006	